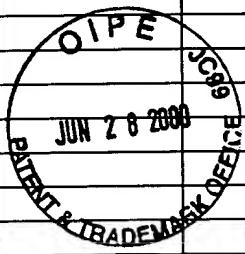


Form PTO-1449 (Rev. 2-32)		U.S. Department of Commerce Patent & Trademark Office	Atty. Docket No. Q56557	Serial No. 09/539,412			
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant: Masaharu OGAWA, et al.					
		Filing Date: March 30, 2000	Group: Not yet assigned	2878			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
SK		4,535,468	8/13/85	Kempter	378/31		
							
FOREIGN PATENT DOCUMENTS							
		Document	Date	Country	Class	Sub-class	Translation Yes/No
SK		10-232824 J	2/9/98	JP	G06F	12/06	abs
SK		10-271374 ✓	9/10/98	JP	H04N	5/225	abs
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
<p><u>"Technique of Processing for Ultra Fine Structure"</u>, Tokuyama Takashi, Ohmsha, pp. 1-11 and pp. 288-301</p>							
EXAMINER: <i>sk Lee</i>		DATE CONSIDERED: <i>4/19/02</i>					
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